

JC986 U.S. PTO  
10/084933  
03/01/02

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10084933	FILING DATE 03/01/2002	CLASS 257	SUBCLASS	GAU 2811	3	EXAMINER <i>E. J. Garcia</i>
<b>**APPLICANTS:</b> Shibata Takeshi; Araki Yasushi;						
<b>**CONTINUING DATA VERIFIED:</b>						
<b>** FOREIGN APPLICATIONS VERIFIED:</b> JAPAN 2001-58834 03/02/2001 JAPAN 2001-58835 03/02/2001						
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>				RESCIND <input type="checkbox"/>		
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiner's initials				ATTORNEY DOCKET NO Q68771		
TITLE : Method for producing organic thin film device and transfer material used therein						

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	Print Claim for O.G.
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		<b>Application Examiner</b>	
		<b>PREPARED FOR ISSUE</b>	
<b>WARNING:</b> The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.			

FILED WITH:

☐ DISK (CRF)

☐ CD-ROM

(Attached in pocket on right inside flap)